thereby sertify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: Commissioner for Patents, Washington, DC 20231, on the date shown below.

Dated: 11/20/02 Signature:

(Marcus J. Millet)

Docket No.: TESSERA 3.0-085 CONT DIV CIP (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Joseph Fjelstad

Application No.: 09/732,821

Group Art Unit: 2827

Filed: December 8, 2000

Examiner: A. Chambliss

For: METHODS FOR MANUFACTURING
RESISTORS USING A SACRIFICAL

LAYER

Commissioner for Patents Washington, DC 20231

REQUEST FOR CONSIDERATION OF INFORMATION UNDER 37 CFR § 1.97 (C)

Dear Sir:

It is respectfully requested that the references cited in the enclosed form be considered pursuant to 37 C.F.R. § 1.97(c). Please charge deposit account No. 12-1095 in the amount of \$180.00 pursuant to 37 C.F.R. § 1.17(p). In the event that any additional fee is due in connection with the present request, the same should be charged to our deposit account No. 12-1095.

Dated: November 20, 2002

Respectfully submitted,

By_

Marcus J. Millet

Registration No.: 28,241 LERNER, DAVID, LITTENBERG, KRUMHOLZ & MENTLIK, LLP

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PTO/SB/08A (10-01)

Approved for use through 10/31/2002 OMB 0651-0031
U. S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Su	Substitute for form 1449A/PTO			Complete if Known		
				Application Number	09/732,821	
INFORMATION DISCLOSURE				Filing Date	December 8, 2000	
5	STATEMENT	BY A	APPLICANT	First Named Inventor	Joseph Fjelstad	
				Art Unit	2827	
	(use as many sl	neets as	necessary)	Examiner Name	A. Chambliss	
Sheet	1	of	1	Attorney Docket Number	TESSERA 3.0-085 CONT DIV CIP	

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite	Document Number Number-Kind Code ² (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant	
	No.1				Passages or Relevant Figures Appear	
	AA	1,948,774	02-27-1934	SIEGEL		
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		FOREI	GN PATENT	OCUMENTS		
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T
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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS					
	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²		

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